ORIGINAL RESEARCH

Development of hardware system using temperature and vibration maintenance models integration concepts for conventional machines monitoring: a case study

Michael Kanisuru Adeyeri[1] · Khumbulani Mpofu[1] · Buliaminu Kareem[2]

Abstract This article describes the integration of temperature and vibration models for maintenance monitoring of conventional machinery parts in which their optimal and best functionalities are affected by abnormal changes in temperature and vibration values thereby resulting in machine failures, machines breakdown, poor quality of products, inability to meeting customers' demand, poor inventory control and just to mention a few. The work entails the use of temperature and vibration sensors as monitoring probes programmed in microcontroller using C language. The developed hardware consists of vibration sensor of ADXL345, temperature sensor of AD594/595 of type K thermocouple, microcontroller, graphic liquid crystal display, real time clock, etc. The hardware is divided into two: one is based at the workstation (majorly meant to monitor machines behaviour) and the other at the base station (meant to receive transmission of machines information sent from the workstation), working cooperatively for effective functionalities. The resulting hardware built was calibrated, tested using model verification and validated through principles pivoted on least square and regression analysis approach using data read from the gear boxes of extruding and cutting machines used for polyethylene bag production. The results got therein confirmed related correlation existing between time, vibration and temperature, which are reflections of effective formulation of the developed concept.

Keywords Maintenance model · Agent hardware system · Conventional machines · Machine conditions monitoring

Introduction

The manufacturing world is fast evolving, revolving and transforming to E-manufacturing especially in the developed world where technological advancement is changing rapidly every second which calls for the introduction and use of sophisticated, knowledge-based and highly intelligent machines for industrial uses. The maintenance of these machines which are purely done on e-maintenance platform as corroborated by Iung et al. (2009) are assisted by the use of inbuilt mechanism through artificial intelligence, expert system, neural network, agents and multi agents software that tends to automatically effect changes, carries out repairs and suggest possible means to avert the intending failures and total breakdown. With this dramatic change, consideration is no more given to the developing and underdeveloped countries as well as the less privileged (those who are into production and manufacturing activities at small scale level) who due to high cost could not adopt the use of these hybrid machines. This category of manufacturers has no option than to continue using the conventional machines at their reach and maintain them using the customary maintenance culture.

It is worth noting at this juncture to define what conventional machines are. According to Adeyeri et al. (2012),

✉ Michael Kanisuru Adeyeri
adeyerimichaeltut@gmail.com; adeyerimk@tut.ac.za

Khumbulani Mpofu
mpofuk@tut.ac.za

Buliaminu Kareem
bkareem@futa.edu.ng

[1] Department of Industrial Engineering, Tshwane University of Technology, Pretoria, South Africa

[2] Department of Mechanical Engineering, The Federal University of Technology, Akure, Nigeria

conventional machines are "machines which are operated manually. These machines are controlled by cams, gears, levers, or screws. Examples of these machines are Lathe, grinding machine, flaking machine, extruding machine and just to mention a few. They indeed needed special attention to safe guard or vouch safe for their functionality and optimal performance as compared to the non-conventional machines which are controlled automatically by integrated computer". In view of this, there should be a platform that bridges the gap between the rich manufacturing industries and the less privileged in the maintenance world or a platform that provides a face lift for the customary approach for maintenance practices. The customary maintenance technique is breakdown maintenance (which is also called unplanned maintenance, or run-to-failure maintenance), takes place only at breakdowns. Therefore this article gives an attempted concept of using an embedded approach in embedding sensors (agent hardware) for monitoring machinery conditions from the perspective view of vibration and temperature effects on machines performance.

The rest of this paper is structured as follows. "Literature review" section offers a brief review of the research in the area of maintenance and sensors description. "Methodology" section outlines the methods involved in developing the hardware components. The validation and verification of the development system are enclosed in "Results and discussion" section. Finally, last section summarizes conclusions of this work and outline guidelines for possible future work.

Literature review

Many researchers have written extensively on maintenance from various dimensions of types, framework, concepts and simulation to modelling theory. The works of Jardine et al. (1999), Koc and Lee (2001), Tao et al. (2003), Lee and Scott (2006), Lu et al. (2007), Mahantesh et al. (2008), Derigent et al. (2009) and Ahmad et al. (2011) were focused on maintenance types be it condition based, preventive and opportunistic. Some work results on maintenance plan, policies, strategies, review and framework had been showcased by Ucar and Qiu (2005), Tsang (2002), Albino et al. (1992), Yuan and Chaing (2000), Hausladen and Bechheim (2004), Dufuaa et al. (2001), Levrat et al. (2008), Iung et al. (2009), Muller et al. (2008) and Peng et al. 2010).

Some research outputs of Albino et al. (1992), Marquez and Herguedes (2002), Marquez et al. (2003), Zineb and Chadi (2001) and Ashraf (2004) are on maintenance models development for evaluation and optimal throughput. Results output through the application of simulation

integration, artificial intelligence, neural network, genetic algorithm and knowledge-based expert into solving maintenance problems are already published by Dufuaa et al. (2001), Zineb and Chadi (2001), Andijani and Dufuaa (2002), Greasly (2005), Oladokun et al. (2006), Mahantesh et al. (2008), Voisin et al. (2010), Babaei et al. (2011) and Jasper et al. (2011).

Of recent times, in early 2000, the e-maintenance paradigm emerged. Technological development revealed that e-maintenance platform utilizes internet networking, intra-netting and Extra-netting based on web technology, sensors application, wireless communications and mobile accessories (Iung and Marquez (2006) and Iung et al. (2009)). With this emerging technology, the concept of this work is therefore hinged on the application of sensors technology in assisting in the monitoring of machines behaviour from the view of vibration and temperature effects.

Lee et al. (2006) discussed that multiple degradation indicators built on sensor signals are the most potent tools needed for the real-time condition monitoring as potential failures could be attributed to many correlated degradation processes. It is in view of this that the present concept of hardware development is initiated. It is on the principle of embedded system.

Embedded systems are electronic systems that are intelligent enough to operate on their own without receiving operating commands from an external source. They are standalone systems which carry out their functions automatically with little supervision and operation. Examples of these systems are Global System for Mobile communication (GSM) handsets, calculators, microwave ovens, digital scrolling display, cameras, mouse, security alarm system, etc. At the centre of any embedded system is microcontroller. The remaining parts of this section are for the literature support of the core components for the proposed hardware (microcontroller, vibration and temperature sensors).

Microcontrollers

A microcontroller is a single chip, self-contained computer which incorporates all the basic components of a personal computer on a much smaller scale. Functionally, it is a programmable single chip which controls a process or a system. Microcontrollers are typically used as embedded controllers where they control part of a larger system such as an appliance, automobile, scientific instrument or a computer peripheral. Physically, a microcontroller is an integrated circuit with pins along each side which are used for power, ground, oscillator, input/output ports, interrupt request signals, reset and control.

There are various manufacturers of microcontrollers like Microchip (PIC series), Atmel (AVR series), Actel,

Motorola (MPC series), Maxim integrated products, Texas instruments, Sharp (ARM series), Panasonic, etc. The microcontroller unit can be programmed in any language ranging from Assembly language to Basic, C, Pascal, as long as a compiler exists to convert the code to its machine equivalent (Muhammad et al. 2011).

Vibration and temperature sensors

The ADXL345 is a small, thin, low power, three-axis accelerometer with high resolution (13-bit) measurement at up to ±16 g. Digital output data are formatted as 16-bit twos complement and is accessible through either a SPI (3- or 4-wire) or I2C digital interface. The ADXL345 is well suited for mobile device applications. It measures the static acceleration of gravity in tilt-sensing applications, as well as dynamic acceleration resulting from motion or shock. Its high resolution (4 mg/LSB) enables measurement of inclination changes <1.0° (OTW 2009). The ACCEL Board is the vibration sensor board made by Microelectronika, it is

built around ADXL345, and the means of communication with the microcontroller is through the Serial Peripheral Interface (SPI). The board can measure vibration in three axes, with a resolution of 16 g (Atmel 2010).

Temperature measurement can be accomplished using several types of sensing mechanisms. Temperature measurement systems generally consist of a sensor, a transmitter, an external power supply (for some types of systems), and the wiring that connects these components. The temperature measurement sensors most commonly used in engineering applications are thermocouples, Resistance Temperature Detectors (RTDs), and infrared (IR) thermometers.

For simplicity, reliability, and relatively low cost, thermocouples are widely used. They are self-powered, eliminating the need for a separate power supply to the sensor. Thermocouples are durable when they are appropriately chosen for a given application. Thermocouples also can be used in high-temperature applications, such as incinerators (Grieb 1992).

Fig. 1 Hardware architecture of the designed concept
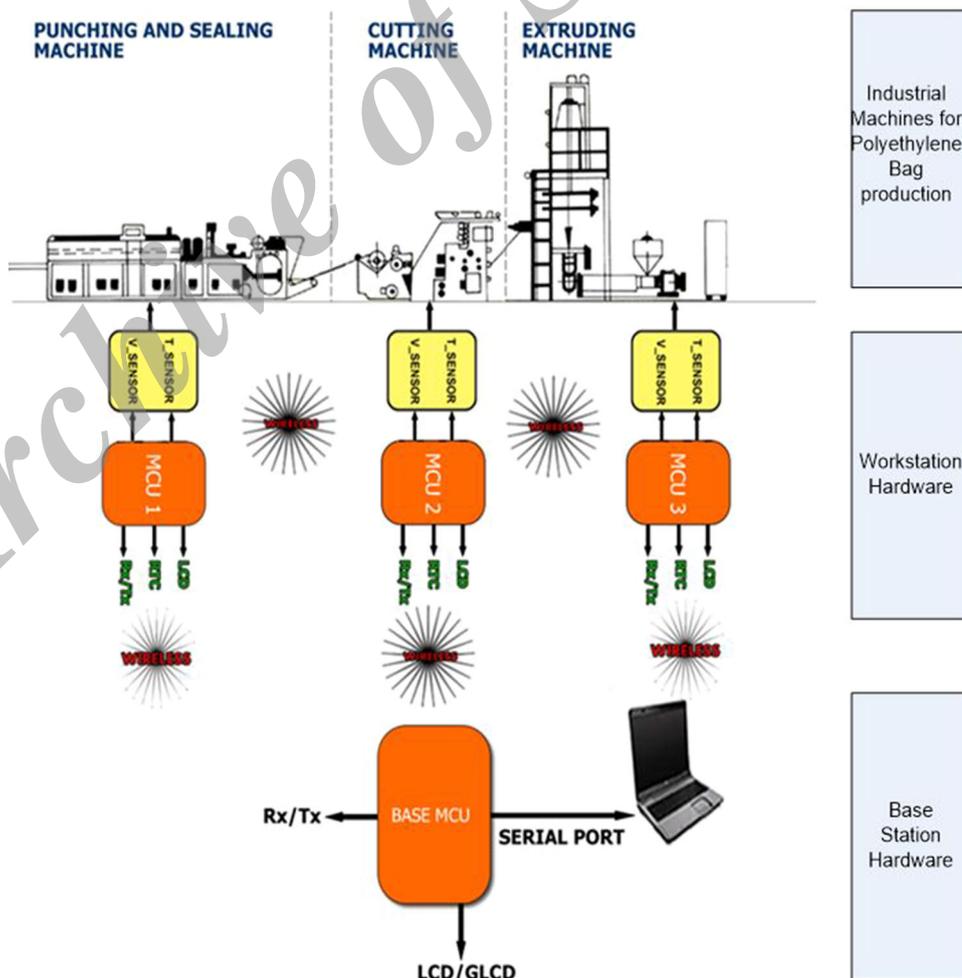
Methodology

The description of the methods behind this concept of maintenance monitoring shall be viewed under monitoring concept formulation, model formulation for vibration and temperature, algorithm formulation, materials needed for the hardware developed and its circuitry and calibration of the developed hardware.

Hardware development for maintenance monitoring concept

The block diagram representing the hardware concept and design for the condition monitoring is as shown in Fig. 1. As depicted, the embedded design consists of a base station embedded system connected directly to a PC and remote machine monitoring systems known as the substation or work station connected directly to the machines which can be produced in the number of machines in the industrial plant of interest.

It is worth noting that only the workstation hardware would be discussed fully in this research article.

Materials for hardware development

The tools and equipment needed for the hardware design and its implementation are as listed:

1. Computer hardware: (Vibration Transducer (ADXL345, AD595, type K thermocouple), AVR Microcontroller (Atmega16; Atmega32); Real Time clock (RTC); Liquid Crystal Display (LCD), MJ MRF24J40MA (2.4 GHz zigbee) transceiver, transformer, capacitor, resistors, MiKroC board platform, and Vero board.
2. Computer software: Microsoft visual studio, C# and C language
3. Auxiliary tools: soldering lead, soldering iron, and USB.

Model formulation

Maintenance based model is formulated from the view of vibrational and temperature effect on machinery.

Temperature-based maintenance model

Adeyeri et al. (2012) assumed that if T_i is the initial temperature value, and T_o defined as the measured temperature before the predicted value of temperature at next planned time of measurement or reading, then the temperature deteriorating factor, U_T is expressed as

$$U_T = \frac{T_i - T_o}{T_m^c} \tag{1}$$

where T_m^c is critical temperature limit level.

Therefore, $T_i^{t_a}$, which is the predicted value of temperature at next planned time of measurement or reading taken, would be

$$T_i^{t_a} = \left[T_i^o + T_i^o U_T \right]_b^{t_n} \tag{2}$$

Simplifying Eq. (2) gives

$$T_i^{t_a} = T_i^o [1 + U_T]_b^{t_n} \tag{3}$$

where t_n is the periodic time numbering of readings and b is a function of speed, environmental condition and product demand.

Therefore, if $T_i^{t_a} \geq T_m^c$, then maintenance is required, otherwise do not.

Vibration-based maintenance model

Dynamic components of machinery do give rise to one form of vibration or another. This vibration generated by its dynamic components is a potent parameter for condition monitoring. Condition monitoring based on vibration measurement and analysis can be carried out either on-load or off-load.

When dealing with Vibration-Based Maintenance (VBM), the condition of significant parts cannot be assessed effectively, i.e. with high certainty, without considering both probabilistic and deterministic aspects of the degradation process. Modelling the time for maintenance action and predicting the value of the vibration level when damage of a significant component is detected are examples of the probabilistic part. However, issues related to machine function, failure analysis and diagnostics are examples of the deterministic part.

Alsyouf (2004) formulated a sub model for predicting vibration level during the next period and until the next measuring moment as stated in Eq. (4). The equation formulated assumed that V be the dependent variable representing the predicted value of the vibration level and that V is a function of three independent variables (V_i, Z, t) and three parameters (a, b, c), for $i = 1, 2...n$, and i is the number of measuring opportunities.

$$V_{i+1} = \left[V_i + ae^{-(b_i t_{i+1} z_i^{c_i})} \right]_k. \tag{4}$$

where V_{i+1} is the predicted value of the vibration level at the next planned measuring time. t_{i+1} the elapsed time since the damage is initiated and its development is detected. V_i the current vibration level value and Z_i the deterioration factor, i.e. the function of the current and anticipated future load and previous deterioration rate.

Fig. 2 Flowchart of condition based maintenance monitoring
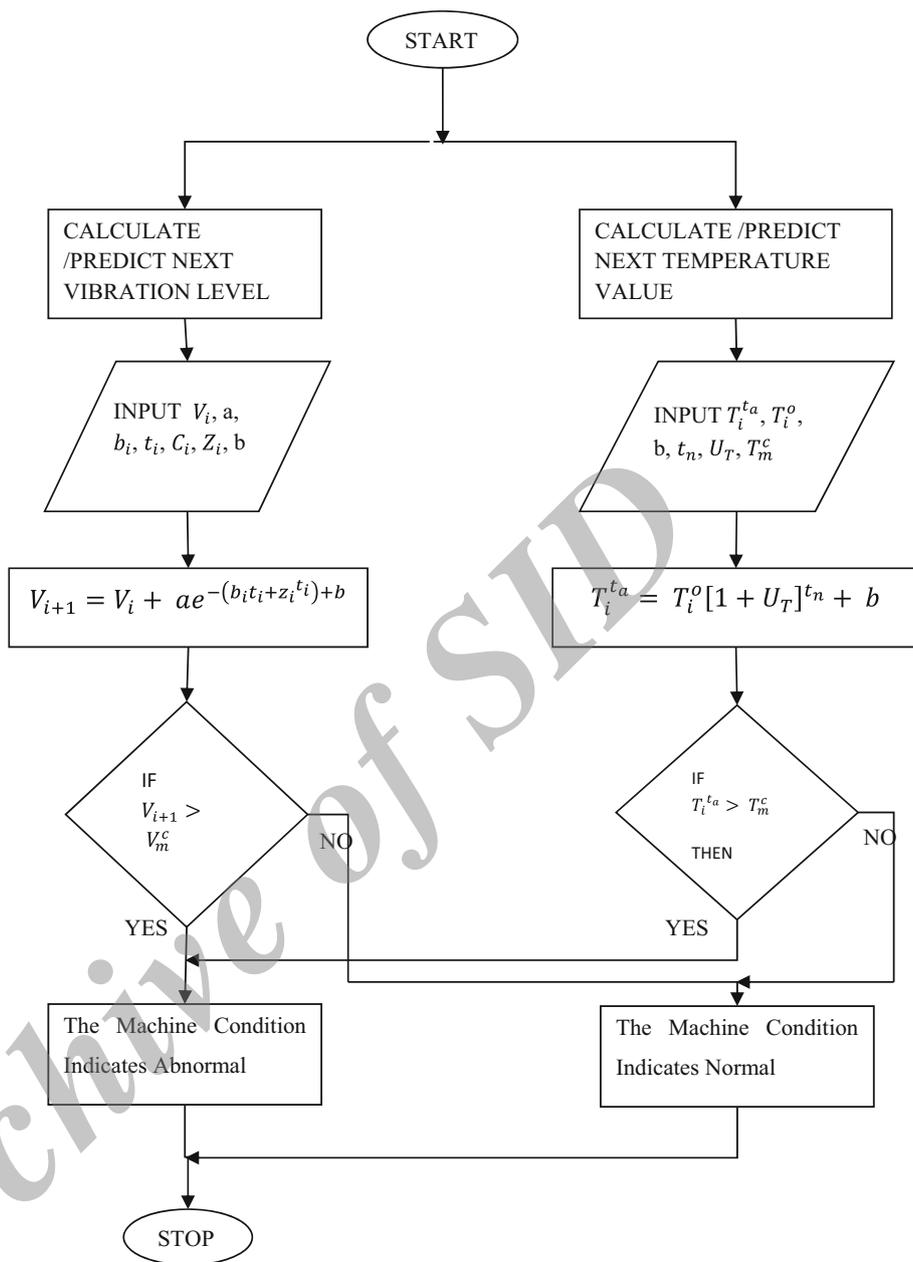
$$Z_i = \left| \frac{V_i - V_O}{V_C} \right| \qquad (5)$$

where V_c is the critical vibration level which is to be supplied by the manufacturer, V_o is the measured vibration before V_{i+1}, a the gradient (slope) by which the value of the vibration level varied since it started to deviate from its normal state (V_o) due to initiation of damage until detecting it at V_p, b_i and c_i are on-linear model's constants, K is a function of loading, speed of machine, environmental condition, and E_i the model error, which is assumed to be

identical, independent and normally distributed with zero mean and constant variance, $N (0, \sigma)$.

When $V_{i+1} \geq V_c$ then maintenance is required, otherwise do not.

Mechanical vibrations a characterised in severity by one and all of these three basic parameters, viz a viz: displacement, velocity or acceleration. Velocity which is best suited for intermediate frequency range has found to give the best indication of severity over the wildest range of frequencies and hence has the wildest application in condition monitoring.
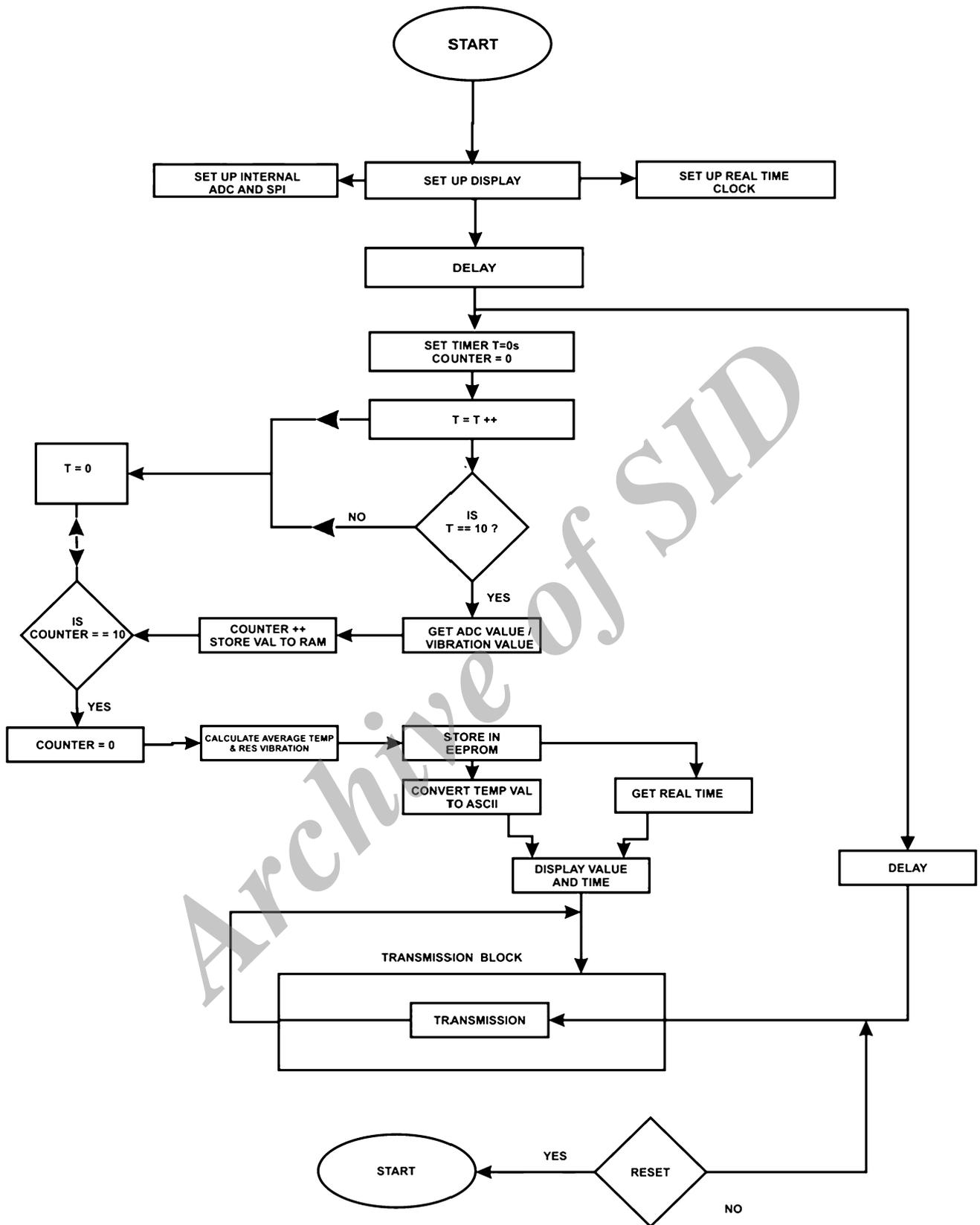
Fig. 3 Flowchart for workstation module

Fig. 4 LCD customization for text display
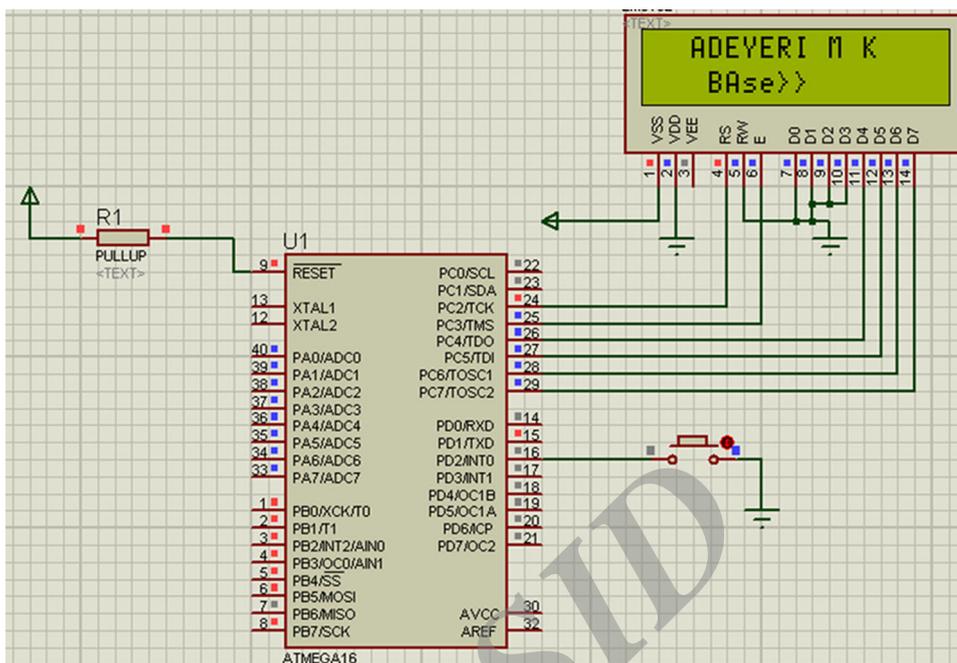
Model flowchart

The flowchart for implementing the vibration and temperature modeis as shown in Fig. 2.

The flowchart used in coding the temperature sensor and the vibration sensor so as to give room for the computer machine interface under the C language is as shown in Fig. 3.

Development of hardware circuitry and interface to the microcontrollers

As depicted in the block diagram of Fig. 1, at the centre of each of the monitoring hardware, there is a microcontroller interfaced to the sensors and other peripherals to enhance human interaction with the system.

According to the pictorial representation, the following hardware was interfaced to the monitoring system:

1. Liquid crystal display(LCD),
2. Real time clock (RTC), and
3. Transceiver.

These are as discussed as regards their operations.

Base station circuitry

Broadly speaking, the base station circuitry is divided into:

1. Serial port circuitry
   The serial port circuitry handles the communication connection of the computer machines hardware interface of the base station with the computer system.

2. Wireless transceiver circuitry
   Another important functionality added to this project is the ability of each monitoring system to be able to communicate with the base station system. In order to establish this, a wireless device was used. The wireless device used for this project is MRF24J40 Zigbee wireless transceiver. An internal transmit/receive (TR) switch combines the transmitter and receiver circuits into differential RFP and RFN pins. These pins are connected to impedance matching circuitry and antenna. An external power amplifier (PA) and could be controlled via the GPIO pins.

3. The display (LCD) circuitry.
   The schematic of Fig. 4 shows the circuitry displayed when it was being simulated on PROTEUS Professional for circuit designs (NIC 2011).

Workstation and base station circuitry design

The workstation circuitry is divided into: temperature sensor circuitry, vibration sensor circuitry, real time clock circuitry, display circuitry, and wireless transceiver circuitry.

The workstation and base station circuitry is as shown in Fig. 5, while Fig. 6a–c shows how the workstation hardware was built.

The development of the hardware was carried out in the following sequence.

1. The schematics design of the hardware was done with the aid of look-up tables, data sheets of the various components being interfaced on Proteus ISIS software.
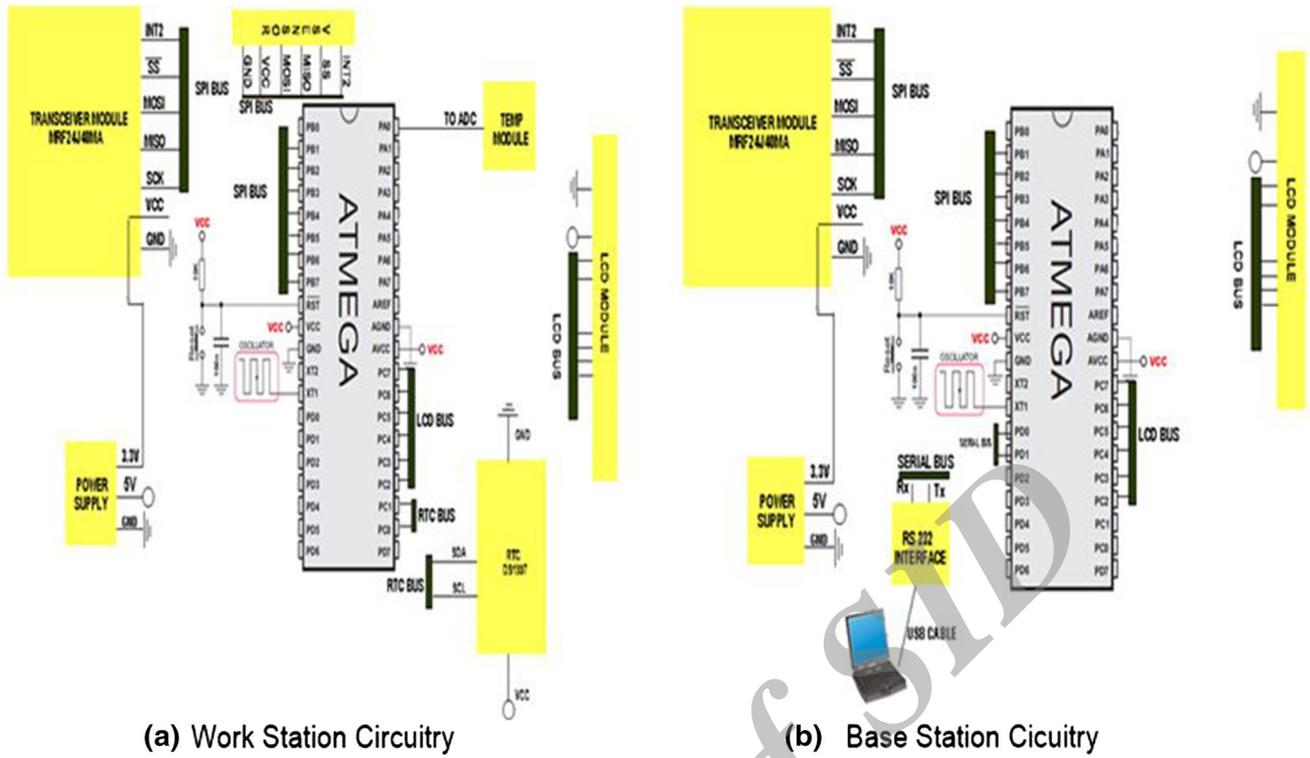
Fig. 5 Circuit diagram for the developed work station and base station
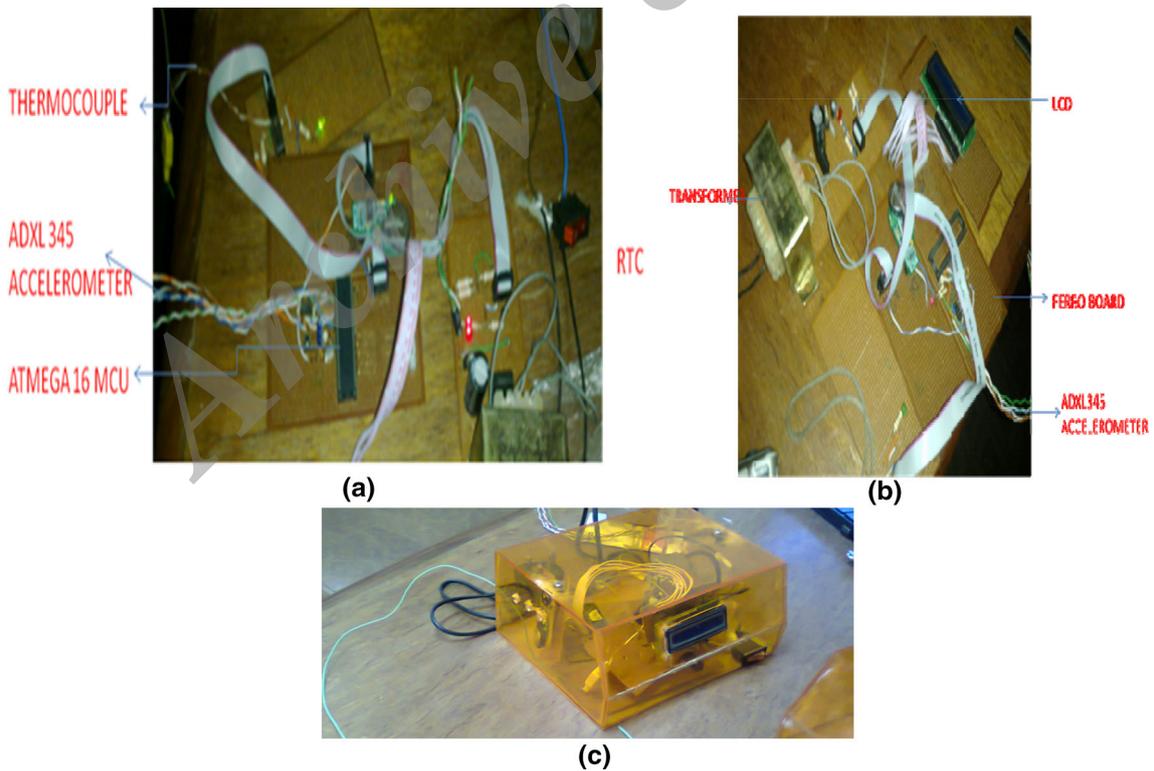
Fig. 6 Workstation hardware components on board at point of testing and the assembled hardware

2. Each component was placed in position on the Vero board and held in connection using soldering leads and a hot soldering iron. This shows the implementation of the designed circuitry for the data acquisition system with some of the components soldered on the Vero board.

3. The embedded programming of ATMEGA32 microcontroller was done by interfacing it with a PC using a programming codes and the MikroC IDE. Program codes written in the C language were converted to their hexadecimal equivalent and written to the EEPROM memory of the microcontroller. The completed device is shown in Fig. 6. All components used were soldered on Vero board and a casing was built for them to give a protection of the device's circuitry.

Hardware circuitry and interface to the microcontrollers of the base station

As depicted in the block diagram of Fig. 5b, the monitoring systems are meant to sense the required conditioning parameters such as temperature and vibration, store the data and each transmits the stored data to the base station over wireless on request by the base station. The base station on the other hand, on receiving the data, transmits the data to the PC via serial port to a standalone windows software application developed to analyse the data and make necessary decisions to enhance maintenance of the machines and productivity. To enhance interactivity with this base station by the users, the following design provision is used:

1. Serial port communication between PC and Base station device, and
2. Graphical liquid crystal display (GLCD) interface.

Power supply

The entire system was powered by a central power supply, which is capable of providing 5, 3.3 and 3.0 V. The design is composed of a voltage transformer, which steps down the 220 V supply to about 16 V. The different sections of the system that need power supply get them from this central supply. The microcontroller for instance needs an absolute 5.0 V supply, the RTC needs 3.0 Volts and the ACCEL board needs 3.3 V and so on. These distributions were made through the effective use of ICU connectors of two by five and two by four jumpers.

Calibration of hardware

The calibration of the temperature thermocouple type K AD595 and the vibration ADXL345 sensors were calibrated based on their specification from their manufacturers (MickroElectronika).

Temperature calibration

To produce a temperature proportional output of 10 mV/°C, and provide an accurate reference junction over the rated operating temperature range, the AD595 is again trimmed at the factory to match the transfer characteristics of Type K thermocouple at +25 °C. At this calibration temperature, the Seebeck coefficient, the rate of change of thermal voltage with respect to temperature at a given temperature is 0.44 μV/°C for a Type K. This corresponds to a gain of 247.3 for the AD595 to realize a 10 mV/°C out-put. Although the device is trimmed for a 250 mV output at +25 °C, an input offset error is induced in the output amplifier resulting in offsets of 11 μV for the AD595 (Joe 2011). To determine the actual output voltage from the AD595, the voltage output, V_o is therefore expressed as

$$V_o = (V_k + 11\,\mu V) \times 247.3 \tag{6}$$

where V_k is the type K voltage. And the corresponding temperature, T °C would be

$$T^oC = \frac{V_o}{10 \text{ mV/}^oC} \tag{7}$$

$$\text{At } 25^\circ C, \quad V_o = 250 \text{ mV} \tag{8}$$

$$\text{and at } X^\circ C, V_o \text{ is} \quad V_o = V_x \text{ mV} \tag{9}$$

where V_x is the voltage read out at corresponding temperature of X °C.

From Eqs. (7) and (9), it implies that change in temperature would be

$$\Delta T = (X - 25)^\circ C \tag{10}$$

and change in voltage be

$$\Delta V = (V_x - 250) \text{ mV} \tag{11}$$

With reference from Eq. (7), change in temperature is therefore expressed as

$$\Delta T \,^\circ C = \frac{\Delta V_o}{10 \text{ mV/}^\circ C} \tag{12}$$

Therefore,

$$X - 25 = \frac{\Delta V}{10 \text{ mV/}^\circ C} \tag{13}$$

Further simplification of Eq. (13) gives X to be

$$X = \left(\frac{\Delta V}{10 \text{ mV/}^\circ C} + 25 \right) \tag{14}$$

when $\Delta V = V_o - 0.25$

Table 1 Vibration and temperature readings from extruder

Time (min)	V (mm/s)	T (°C)	Time (min)	V*(mm/s)	T (°C)	Time (min)	V (mm/s)	T (°C)
1	1.000	35.50	51	0.980	45.80	101	1.420	50.90
2	1.000	35.52	52	1.100	45.90	102	1.440	51.00
3	1.000	35.54	53	1.100	46.00	103	1.460	51.00
4	1.010	35.56	54	1.100	46.10	104	1.480	51.00
5	1.010	35.58	55	1.100	46.20	105	1.500	51.00
6	1.010	35.60	56	1.100	46.30	106	1.520	51.00
7	1.010	35.62	57	1.100	46.40	107	1.540	51.00
8	1.010	36.02	58	1.100	46.50	108	1.560	51.00
9	1.020	36.42	59	1.100	46.60	109	1.550	51.00
10	1.020	36.82	60	1.100	46.70	110	1.540	51.00
11	1.020	37.22	61	1.100	46.80	111	1.530	51.00
12	1.020	37.62	62	1.100	46.90	112	1.520	51.00
13	1.020	38.02	63	1.100	47.00	113	1.510	51.00
14	1.030	38.42	64	1.100	47.10	114	1.500	51.00
15	1.030	38.82	65	1.100	47.20	115	1.490	51.00
16	1.030	39.22	66	1.100	47.30	116	1.480	51.00
17	1.020	39.62	67	1.100	47.40	117	1.470	51.00
18	1.020	40.02	68	1.100	47.50	118	1.460	51.00
19	1.020	40.42	69	1.100	47.60	119	1.450	51.00
20	1.010	40.82	70	1.100	47.70	120	1.440	51.00
21	1.010	41.22	71	1.100	47.80	121	1.430	51.00
22	1.010	41.62	72	1.100	47.90	122	1.420	51.00
23	1.000	42.02	73	1.100	48.00	123	1.410	51.00
24	1.000	42.42	74	1.100	48.10	124	1.400	51.00
25	1.000	42.82	75	1.100	48.20	125	1.390	51.00
26	1.000	43.22	76	1.100	48.30	126	1.380	51.00
27	0.990	43.62	77	1.100	48.40	127	1.370	51.00
28	0.990	44.02	78	1.100	48.50	128	1.360	51.00
29	0.990	44.50	79	1.100	48.60	129	1.350	51.00
30	0.980	44.50	80	1.100	48.70	130	1.340	51.00
31	0.980	44.50	81	1.100	48.80	131	1.330	51.00
32	0.980	44.50	82	1.100	48.90	132	1.320	51.00
33	0.970	44.50	83	1.100	49.00	133	1.310	51.00
34	0.970	44.50	84	1.100	49.10	134	1.300	51.00
35	0.970	44.50	85	1.100	49.20	135	1.290	51.00
36	0.970	44.50	86	1.100	49.30	136	1.280	51.00
37	0.960	44.50	87	1.120	49.40	137	1.270	51.00
38	0.960	44.50	88	1.140	49.50	138	1.260	51.00
39	0.960	44.50	89	1.160	49.60	139	1.250	51.00
40	0.950	44.60	90	1.180	49.70	140	1.240	51.00
41	0.960	44.70	91	1.200	49.80	141	1.260	51.00
42	0.960	44.80	92	1.220	49.90	142	1.280	51.00
43	0.960	44.90	93	1.240	50.00	143	1.300	51.00
44	0.960	45.00	94	1.260	50.10	144	1.320	51.00
45	0.960	45.10	95	1.280	50.20	145	1.340	51.00
46	0.970	45.20	96	1.300	50.30	146	1.360	51.00
47	0.970	45.30	97	1.320	50.40	147	1.380	51.00
48	0.970	45.40	98	1.340	50.50	148	1.400	51.00
49	0.970	45.50	99	1.360	50.60	149	1.420	51.00
50	0.970	45.60	100	1.380	50.70	150	1.440	51.00

V vibration, *T* temperature

Table 2 Correlation of time, vibration and temperature data

	Time of readings (min)	Vibration value (mm/s)	Temp (°C)
Time of readings (min)	1		
Vibration value (mm/s)	0.840634	1	
Temp (°C)	0.917332	0.746613	1
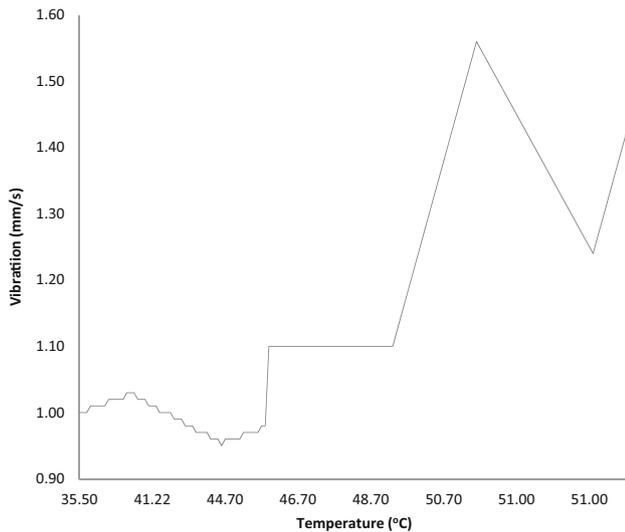
Fig. 7 Graph of vibration against temperature

Fig. 8 Curve fitting on vibration data for vibration model calibration
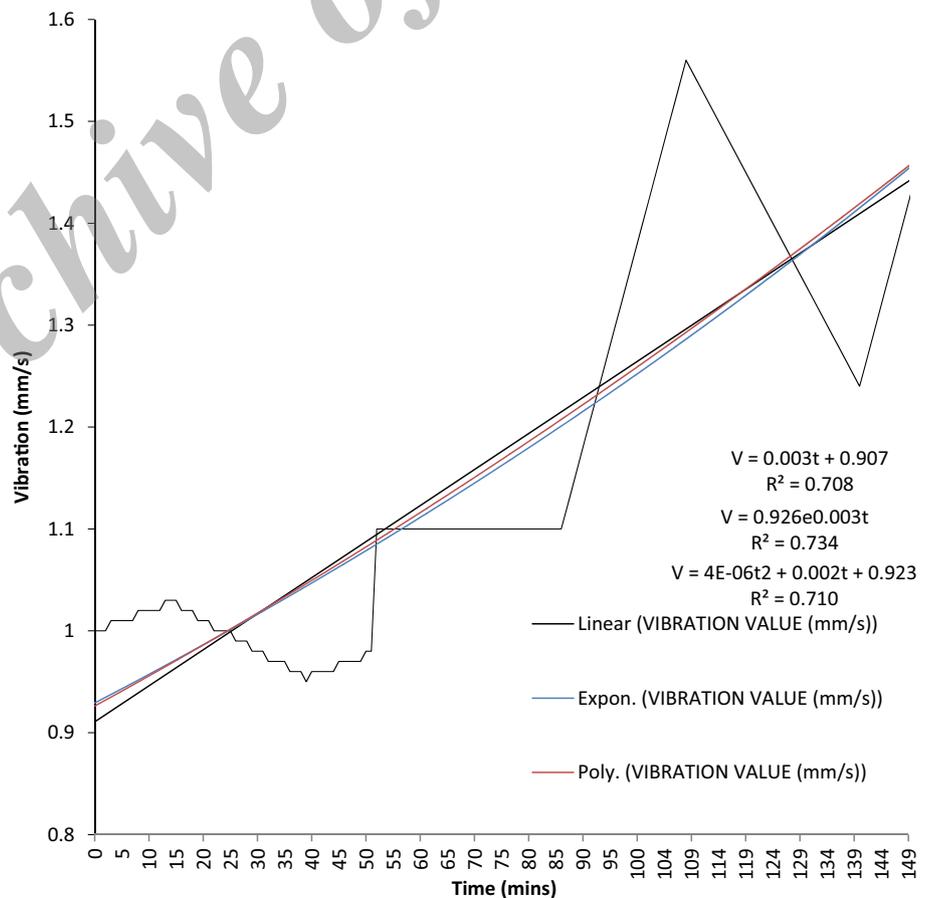
$$\Delta T = X - 25$$

and "X °C" which is the present read out value would be

$$X = \Delta T + 25. \tag{15}$$

Vibration calibration

Accel SPI board of ADXL345 measures vibration in x, y and z axes. Adopting the principle of OTW (2009), the effective calibrated vibration V_b was got from the expression of (Eq. 16). As

$$V_b = \sqrt{x^2 + y^2 + z^2} \tag{16}$$

The hardware was used in taking readings on their embedment into machines to see if the calibration is perfectly done. The readings obtained and the regression

On Fig. 8:

V = 0.003t + 0.907
R² = 0.708

V = 0.926e0.003t
R² = 0.734

V = 4E-06t2 + 0.002t + 0.923
R² = 0.710

Linear (VIBRATION VALUE (mm/s))

Expon. (VIBRATION VALUE (mm/s))

Poly. (VIBRATION VALUE (mm/s))

Fig. 9 Temperature data curve fitting for model calibration

$T = 0.096t + 39.69$
$R^2 = 0.841$

$T = 39.73e^{0.002t}$
$R^2 = 0.807$

$T = -0.001t^2 + 0.243t + 36.04$
$R^2 = 0.974$

—— Linear (TEMP (OC))
—— Expon. (TEMP (OC))
—— Poly. (TEMP (OC))
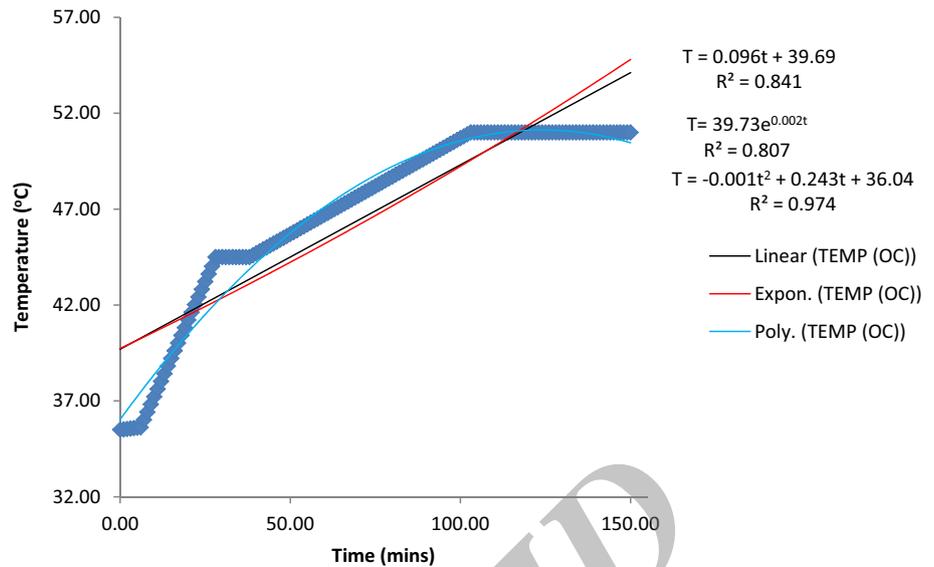
Table 3 Observed and predicted vibration data from gear box of extruder

Time (min)	OV (mm/s)	PV (mm/s)	Time (min)	OV (mm/s)	PV (mm/s)	Time (min)	OV (mm/s)	PV (mm/s)
1	1.010	0.930	51	1.000	1.080	101	1.300	1.260
2	1.010	0.930	52	1.000	1.080	102	1.300	1.260
3	1.010	0.930	53	1.000	1.090	103	1.300	1.260
4	1.010	0.940	54	1.100	1.090	104	1.300	1.270
5	1.010	0.940	55	1.100	1.090	105	1.300	1.270
6	1.010	0.940	56	1.100	1.100	106	1.300	1.280
7	1.010	0.940	57	1.100	1.100	107	1.300	1.280
8	1.000	0.950	58	1.100	1.100	108	1.220	1.280
9	1.000	0.950	59	1.100	1.110	109	1.220	1.290
10	1.000	0.950	60	1.100	1.110	110	1.220	1.290
11	1.000	0.960	61	1.100	1.110	111	1.220	1.290
12	1.000	0.960	62	1.100	1.120	112	1.220	1.300
13	1.000	0.960	63	1.100	1.120	113	1.220	1.300
14	1.000	0.960	64	1.100	1.120	114	1.220	1.310
15	1.020	0.970	65	1.100	1.130	115	1.220	1.310
16	1.020	0.970	66	1.100	1.130	116	1.290	1.310
17	1.020	0.970	67	1.120	1.130	117	1.290	1.320
18	1.020	0.980	68	1.140	1.140	118	1.290	1.320
19	1.020	0.980	69	1.160	1.140	119	1.290	1.330
20	1.020	0.980	70	1.180	1.140	120	1.290	1.330
21	1.020	0.990	71	1.200	1.150	121	1.240	1.330
22	1.020	0.990	72	1.120	1.150	122	1.240	1.340
23	1.080	0.990	73	1.120	1.160	123	1.240	1.340
24	1.080	0.990	74	1.120	1.160	124	1.240	1.350
25	1.080	1.000	75	1.120	1.160	125	1.240	1.350
26	1.080	1.000	76	1.120	1.170	126	1.240	1.350
27	1.080	1.000	77	1.120	1.170	127	1.240	1.360
28	1.080	1.010	78	1.120	1.170	128	1.280	1.360
29	1.080	1.010	79	1.120	1.180	129	1.280	1.370
30	1.080	1.010	80	1.120	1.180	130	1.280	1.370

Table 3 continued

Time (min)	OV (mm/s)	PV (mm/s)	Time (min)	OV (mm/s)	PV (mm/s)	Time (min)	OV (mm/s)	PV (mm/s)
31	1.080	1.020	81	1.120	1.180	131	1.280	1.370
32	1.080	1.020	82	1.120	1.190	132	1.280	1.380
33	1.080	1.020	83	1.120	1.190	133	1.280	1.380
34	1.080	1.020	84	1.120	1.190	134	1.280	1.390
35	1.080	1.030	85	1.120	1.200	135	1.280	1.390
36	1.080	1.030	86	1.120	1.200	136	1.340	1.400
37	1.080	1.030	87	1.200	1.200	137	1.340	1.400
38	1.000	1.040	88	1.200	1.210	138	1.340	1.400
39	1.000	1.040	89	1.200	1.210	139	1.340	1.410
40	1.000	1.040	90	1.200	1.220	140	1.340	1.410
41	1.000	1.050	91	1.200	1.220	141	1.340	1.420
42	1.000	1.050	92	1.200	1.220	142	1.340	1.420
43	1.000	1.050	93	1.200	1.230	143	1.340	1.430
44	1.000	1.060	94	1.200	1.230	144	1.340	1.430
45	1.000	1.060	95	1.200	1.230	145	1.340	1.430
46	1.000	1.060	96	1.200	1.240	146	1.340	1.440
47	1.000	1.070	97	1.200	1.240	147	1.260	1.440
48	1.000	1.070	98	1.300	1.250	148	1.260	1.450
49	1.000	1.070	99	1.300	1.250	149	1.260	1.450
50	1.000	1.070	100	1.300	1.250	150	1.260	1.460

OV observed vibration values, *PV* predicted vibration values

Table 4 Observed and predicted temperature data from electric motor of cutting machine

Time (min)	OT (°C)	PT (°C)	Time (min)	OT (°C)	PT (°C)	Time (min)	OT (°C)	PT (°C)
1	36.00	36.53	52	42.00	47.82	102	48.00	53.86
2	36.00	36.80	53	43.00	47.99	103	48.00	53.93
3	36.00	37.07	54	43.00	48.15	104	48.00	53.99
4	36.00	37.34	55	43.00	48.32	105	48.00	54.06
5	36.00	37.61	56	43.00	48.48	106	48.00	54.12
6	36.00	37.87	57	43.00	48.65	107	48.00	54.19
7	38.00	38.13	58	43.00	48.80	108	48.00	54.25
8	38.00	38.39	59	43.00	48.96	109	49.00	54.30
9	38.00	38.65	60	43.00	49.12	110	49.00	54.36
10	38.00	38.90	61	43.00	49.27	111	49.00	54.41
11	38.00	39.15	62	43.00	49.42	112	49.00	54.47
12	38.00	39.40	63	43.00	49.57	113	49.00	54.52
13	38.00	39.65	64	44.00	49.72	114	49.00	54.56
14	39.00	39.90	65	44.00	49.87	115	49.00	54.61
15	39.00	40.15	66	44.00	50.01	116	49.00	54.66
16	39.00	40.39	67	44.00	50.15	117	49.00	54.70
17	39.00	40.63	68	44.00	50.29	118	49.00	54.74
18	39.00	40.87	69	44.00	50.43	119	49.00	54.78
19	39.00	41.11	70	44.00	50.56	120	49.00	54.81
20	39.00	41.34	71	44.00	50.70	121	50.00	54.85
21	39.00	41.58	72	44.00	50.83	122	50.00	54.88
22	39.00	41.81	73	44.00	50.96	123	50.00	54.91
23	39.00	42.04	74	44.00	51.09	124	50.00	54.94

Table 4 continued

Time (min)	OT (°C)	PT (°C)	Time (min)	OT (°C)	PT (°C)	Time (min)	OT (°C)	PT (°C)
24	40.00	42.26	75	44.00	51.21	125	50.00	54.96
25	40.00	42.49	76	44.00	51.34	126	50.00	54.99
26	40.00	42.71	77	45.00	51.46	127	50.00	55.01
27	40.00	42.93	78	45.00	51.58	128	50.00	55.03
28	40.00	43.15	79	45.00	51.70	129	50.00	55.05
29	40.00	43.37	80	45.00	51.81	130	50.00	55.06
30	40.00	43.58	81	45.00	51.93	131	50.00	55.08
31	40.00	43.80	82	45.00	52.04	132	50.00	55.09
32	40.00	44.01	83	46.80	52.15	133	50.00	55.10
33	41.00	44.22	84	46.80	52.26	134	50.00	55.11
34	41.00	44.43	85	46.80	52.36	135	50.00	55.12
35	41.00	44.63	86	46.80	52.46	136	50.00	55.12
36	41.00	44.83	87	46.80	52.57	137	50.00	55.12
37	41.00	45.04	88	46.80	52.67	138	52.00	55.12
38	41.00	45.24	89	46.80	52.76	139	52.00	55.12
39	41.00	45.43	90	46.80	52.86	140	52.00	55.12
40	41.00	45.63	91	46.80	52.95	141	52.00	55.11
41	41.00	45.82	92	47.00	53.05	142	52.00	55.10
42	42.00	46.01	93	47.00	53.14	143	52.00	55.10
43	42.00	46.20	94	47.00	53.22	144	52.00	55.08
44	42.00	46.39	95	47.00	53.31	145	52.00	55.07
45	42.00	46.58	96	47.00	53.39	146	52.00	55.05
46	42.00	46.76	97	47.00	53.48	147	52.00	55.04
47	42.00	46.94	98	47.00	53.56	148	52.00	55.02
48	42.00	47.12	99	47.00	53.63	149	52.00	55.00
49	42.00	47.30	100	48.00	53.71	150	52.00	54.97
50	42.00	47.47						

OT observed temperature values, *PT* predicted temperature values

analyses of curve fittings on them for verification of the calibration were fully discussed in subsequent section.

Results and discussion

A polyethylene bag production industry was used as case study for the implementation of the developed hardware. The key machines utilized are extruding machine, cutting, sealing and punching machines were the main machines in which the built hardware were used on.

Data verification and analysis

The temperature and vibration models developed were verified using some of the data collected from the machines by carrying out curve fitting on them.

Table 1 gives the extracted data of machines' vibration and temperature. A correlation test was performed to know if the parameters considered were related. The correlation result displayed in Table 2 shows that vibration tends to increase as time increases since the value of R^2 value is 0.841 which is almost 1. Also temperature is correlated with time since the R^2 value is 0.917.

Consequently, the R^2 value of 0.7466 arrived at gave the indication that there exit a correlation relationship between vibration and temperature. Plotting the values of these factors against each other, a nonlinear relationship was got as depicted on Fig. 7. However, the relationship is non-linear, but there is indication that as vibration increases with time, temperature also increases.

The vibration verification was done using the developed hardware system to retrieve data from the polyethylene bag production machines. Some data were extracted from the retrieved data as seen in Table 2. The verification principle adopted is the curve fitting/Goodness of fit approach. The data in Table 2 was plotted and the result is as shown in Fig. 8. From this figure, three curves fitting were done, namely; linear, exponential and polynomial, while Eqs. (17), (18) and (19), respectively, described their
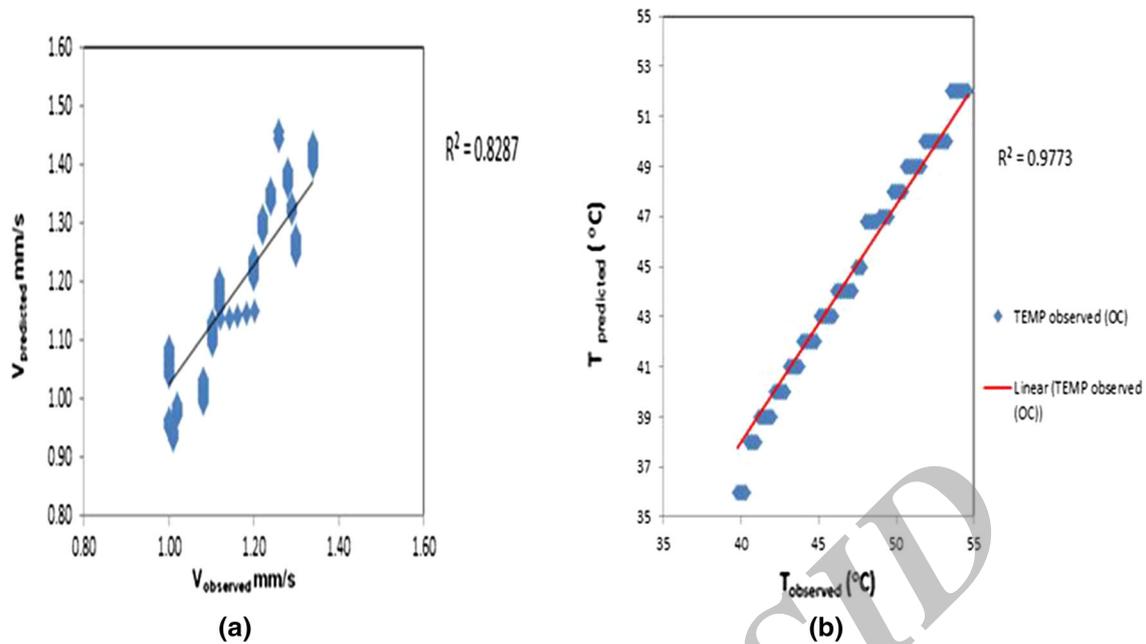
Fig. 10 **a** Graph of vibration model validation, **b** temperature model validation

mathematics formulation and their corresponding R^2 values.

$$V = 0.003t + 0.91 \qquad (17)$$

and its $R^2 = 0.706$

$$V = 0.928\ell^{0.003t} \qquad (18)$$

and its $R^2 = 0.734$

$$V = 0.000004t^2 + 0.002t + 0.925 \qquad (19)$$

and its $R^2 = 0.708$

The exponential line or curve of best fit was picked based on the value of R^2, which is closest to value one (1) as compared to the other curves. This is a confirmation of the formulated vibration model of Eq. (4).

Similarly, the temperature calibration was done using the developed hardware system for both the substation and

base-station to retrieve data from the polyethylene bag production machines. The temperature data in Table 2 was plotted and the result is as shown in Fig. 8. From this figure, three curves fitting were done, namely; linear, exponential and polynomial. The equations describing the various curves and their corresponding R^2 values are as stated in Eqs. (20), (21) and (22).

$$T = 0.096t + 39.69 \qquad (20)$$

and its $R^2 = 0.841$

$$T = 39.73\ell^{0.002t} \qquad (21)$$

and its $R^2 = 0.807$

$$T = -0.000t^2 + 0.243t + 36.04 \qquad (22)$$

and its $R^2 = 0.974$

Table 5 Anova analysis of the observed and predicted vibration data of gear box of extruder

Groups	Count	Sum	Average	Variance
Summary				
Time (min)	150	11325	75.5	1887.5
OV (mm/s)	150	172.44	1.1496	0.013026685
PV (mm/s)	150	175.89	1.1726	0.023730779
Source of variation	SS	df	MS	F	p value	F crit
ANOVA						
Between groups	552627.245	2	276313.6	439.1654172	3.2E − 106	3.015899
Within groups	281242.9769	447	629.1789			
Total	833870.2219	449				

Table 6 Anova analysis of the observed and predicted temperature data of electric motor of cutting machine

Groups	Count	Sum	Average	Variance
Summary				
Time (min)	148	11,173	75.49324324	1904.673423
OT (°C)	148	6631.2	44.80540541	20.99697739
PT (°C)	148	7310.05	49.39222973	31.99060928

Source of variation	SS	df	MS	F	p value	F crit
ANOVA						
Between groups	81,106.23258	2	40,553.11629	62.14525816	1.67E−24	3.016175
Within groups	287,776.1685	441	652.55367			
Total	368,882.4011	443				

The linear line or curve of best fit was picked because the value of R^2 of the linear curve is closer to one than that of the exponential curve. Also the equation of polynomial curve of second order is attesting to the fact that it should be linear as the coefficient of t^2 is −0.00. And this supported the formulated temperature model of Eq. (3) (Fig. 9).

Model validation

The model equations developed were used to predict values for machines vibration and temperature. The observed readings from the hardware and the predicted values of the developed equations for vibration and temperature are as tabulated in Tables 3 and 4, respectively.

As depicted in Fig. 10a, the predicted vibration data were plotted against the observed values to determine the vibration model validity.

The R value of 0.909 (which is almost 91 %) got from the plotted data as contained in Fig. 10a showed that the vibration model calibrated on the sensor is accurate to define the vibration behavior of the machine since it is closer to the value of one (1).

Also, Fig. 10b displayed the one-to-one plotting of the data in Table 4. The predicted temperature values were plotted against the observed values so as to determine the temperature model validity.

Consequently, using Tables 3 and 4 for the ANOVA analysis of the observed and predicted data, Tables 5 and 6 resulted therein.

The R value of 0.988 (which is almost 99 %) got from the plotted data as contained in Fig. 10b showed that the temperature model calibration is accurate to define the temperature characteristics of the machine since it is closer to the value of one (1). Also, the ANOVA analysis of the vibration and temperature data observed and predicted shows that the respective p values of 3.2×10^{-106} and 1.67×10^{-24} is an indication that the calibration of the hardware systems is highly significant.

Conclusion

This paper suggests a novel mechanism for machine condition monitoring of conventional machines using the developed hardware. The condition monitoring of production machines as means of monitoring machines' condition was achieved through the hardware developed for workstation and base station. The work-station hardware through the ADXL345 vibration sensor and type K thermocouple among other components embedded in it monitored the vibration and temperature of the machines, respectively. The behavioral patterns of the machines communicated to the base station hardware through a wireless transceiver were received from the computer system connected to the base station through universal serial bus port.

The paper established that there is correlation between time, vibration and temperature. As vibration increases with time, temperature also increases. Also, it has provided a platform of real time monitoring for conventional machines.

Due to lack of appropriate test equipment, it is recommended that further work should be done on work station hardware development that would accommodate the detection of fluid lubrication wear that occurs during operation and severe fatigue wear resulting from rolling contact fatigue in dry lubrication. Future work can be carried out by extending this approach to a system with multiple deterioration measures, and with multiple subsystems or multiple deterioration failure modes.

References

Adeyeri MK, Kareem B, Aderoba AA, Adewale OS (2012) Temperature based embedded programming algorithm for conventional machines condition monitoring proceedings of the fourth international conference on future computing technology, international academy, research and industrial association (IARIA), Nice-France, pp 51–57

Ahmad R, Kamaruddin S, Azid I, Almanar I (2011) Maintenance management decision model for preventive maintenance strategy on production equipment. J Ind Eng Int 7(13):22–34

Albino V, Carella G, Okogbaa O (1992) Maintenance polices in just-in-time manufacturing lines. Int J Prod Res 30:369–382

Alsyouf I (2004) Cost effective maintenance for competitive advantages. Thesis for the degree of doctor of philosophy (terotechnology), School of Industrial Engineering, Växjö University, Sweden

Andijani A, Duffuaa S (2002) Critical evaluation of simulation studies in maintenance systems. Prod Plan Control 13(4):336–341

Ashraf WL (2004) A decision analysis model for maintenance policy selection using a CMMS. J Qual Maint Eng 10(3):191–202

Atmel (2010) 8-bit Microcontroller with 16 K bytes in-system programmable flash ATmega16. Atmel Incorporation, San Jose

Babaei H, Shahanaghi K, Bakhsha A (2011) A new approach for constraining failure probability of a critical deteriorating system Yard crane scheduling in port container terminals using genetic algorithm. J Ind Eng Int 7(12):52–59

Derigent W, Thomas E, Levrat E, Iung B (2009) Opportunistic maintenance based on fuzzy modelling of component proximity. CIRP Ann Manuf Technol 58:29–32

Duffuaa SO, Ben-Daya M, Al-Sultan KS, Andijani AA (2001) A generic conceptual simulation model for maintenance systems. J Qual Maint Eng 7(3):34–40

Greasly A (2005) Using system dynamics in a discrete-event simulation study of a manufacturing plant. Int J Oper Prod Manag 25(6):534–548

Grieb B (1992) Temperature measurement in process control. Advances in instrumentation and control, proceedings of the annual meeting of the instrument society of America, vol 47, Instrument Society of America, Research Triangle Park, North Carolina

Hausladen I, Bechheim C (2004) E-maintenance platform as a basis for business process integration. In: Proceedings of INDIN04, international conference on industrial informatics, pp 46–51

Iung B, Marquez CA (2006) Special issue on e-Maintenance. Comput Ind 57(6):473–606

Iung B, Levrat E, Marquez AC, Erbe H (2009) Conceptual framework for e-Maintenance: illustration by e-Maintenance technologies and platforms. Annu Rev Control 33(2009):220–229

Jardine AKS, Joseph T, Benjevic D (1999) Optimising condition-based maintenance decisions for equipment subject to vibration monitoring. J Qual Maint Eng 5(3):192–202. (http://www.emerald-library.com). Retrieved: June, 2012

Jasper V, Warse K, Hans W (2011) Managing condition-based maintenance technology, a multiple case study in the process industry. J Qual Maint Engi 17 (1): 40–62. (http://www.emerald-library.com. June, 2012)

Joe M (2011) Application note on thermocouple signal conditioning using the AD594/AD595. One Technology Way Norwood, USA. (http://www.analog.com. Accessed 26 Nov 2011)

Koc M, Lee J (2001) A system framework for next-generation e-Maintenance system. 2nd International symposium on environmentally conscious design and inverse manufacturing

Lee J, Scott LW (2006) Zero-breakdown machines and systems: productivity needs for next-generation maintenance. Eng Asset Manag 2006:31–43

Lee J, Ni J, Djurdjanovic D, Qiu H, Liao H (2006) Intelligent prognostic tools and e-maintenance. Comput Ind 57:476–489

Levrat E, Iung B, Marquez CA (2008) e-Maintenance: review and conceptual framework. Prod Plan Control 19(4):408–429

Lu S, Tu YC, Lu H (2007) Predictive condition-based maintenance for continuously deteriorating systems. Qual Reliab Eng Int 23:71–81. doi:10.1002/qre.823

Mahantesh N, Ramachandra A, Satosh Kumar AN (2008) Artificial intelligence-based condition monitoring for plant maintenance. Assem Autom 28(2):143–150

Marquez AC, Herguedas SA (2002) Models for maintenance optimization: a study for repairable systems and finite time periods. Reliab Eng Syst Saf 75(3):367–377

Marquez CA, Gupta JND, Herguedas SA (2003) Maintenance policies for a production system with constrained production rate and buffer capacity. Int J Prod Res 41(9):1909–1926

Muhammad AM, Sarmad N, Sepehr N (2011) The AVR microcontroller and embedded systems using assembly and C. Prentice Hall, London

Muller A, Suhner MC, Iung B (2008) Proactive maintenance for industrial system operation based on a formalised prognosis process. Reliab Eng Syst Saf 93(2):234–253

NIC-National Instruments Corporation (2011) Proteus software, National Instruments Corporation, Mopac Expwy Austin TX 78759-3504. http://www.ni.com/academic/circuits. Accessed 08 May 2011

Oladokun VO, Charles-Owaba OE, Nwaouzru CS (2006) An application of artificial neural network to maintenance management. J Ind Eng Int 2(3):19–26

OTW-One Technology Way (2009) "ADXL345 Data sheet", analog devices, One Technology Way, USA. http://www.analog.com. Accessed 08 Oct 2011

Peng Y, Dong M, Zuo MJ (2010) Current status of machine prognostics in condition-based maintenance—a review. Int J Adv Manuf Technol 50:293–313

Tao B, Ding H, Xion YL (2003) IP sensor and its distributed networking application in e-Maintenance. In: Proceedings of the 2003 IEEE international conference on systems, man and cybernetics, vol 4, pp 3858–3863

Tsang A (2002) Strategic dimensions of maintenance management. JQME 8(1):7–39

Uca M, Qiu RG (2005) e-Maintenance in support of e-automated manufacturing systems. J Chin Inst Ind Eng 22(1):1–10

Voisin A, Levrat E, Cocheteux P, Iung B (2010) Generic prognosis model for proactive maintenance decision support: application to pre-industrial e-maintenance test. J Intell Manuf 21:177–193

Yuan J, Chaing J (2000) Optimal maintenance policy for a production system subject to aging and shocks. J Qual Maint Eng 6(3):200–216

Zineb S, Chadi S (2001) Maintenance integration in manufacturing systems: from the modeling tool to evaluation. Int J Flex Manuf Syst 13(3):267–285